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PTO/SB/08a (08-03)

Approved for use through 07/31/2006. OMB 0651-0031  
U.S. Patent and Trademark Office: U.S. DEPARTMENT OF COMMERCE

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Substitute for form 1449A/PTO

## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Application Number	10/732,904
Filing Date	December 10, 2003
First Named Inventor	Kim, et al.
Group Art Unit	Unassigned 2818
Examiner Name	Unassigned
Attorney Docket Number	AMAT/6826.P1/DSM/BCVD/JW

Sheet

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of

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Submission Date

February 18, 2004

### U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code <sup>2</sup> (if known)			
PD	A1	US-6,596,465	07/22/2003	Mangat, et al.	
	A2	US-6,573,030	06/03/2003	Fairbairn, et al.	
	A3	US-6,541,397B1	04/01/2003	Bencher	
	A4	US-6,514,667	02/04/03	Angelopoulos, et al.	
	A5	US-6,511,909	01/28/03	Yau, et al.	
	A6	US-6,511,903	01/28/03	Yau, et al.	
	A7	US-6,500,772	12/31/02	Chakravarti, et al.	
	A8	US-6,497,963	12/24/02	Grill, et al.	
	A9	US-6,492,731	12/10/02	Catabay, et al.	
	A10	US-6,489,233	12/03/02	Chooi, et al.	
	A11	US-6,485,815	11/26/02	Jeong, et al.	
	A12	US-6,482,754	11/19/02	Andideh, et al.	
	A13	US-6,479,409	11/12/02	Shioya, et al.	
	A14	US-6,479,408	11/12/02	Shioya, et al.	
	A15	US-6,479,407	11/12/02	Yokoyama, et al.	
	A16	US-6,479,110	11/12/02	Grill, et al.	
PD	A17	US-6,472,317	10/29/02	Wang, et al.	
PD	A18	US-6,472,264	10/29/02	Agarwal	

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		Number-Kind Code <sup>2</sup> (if known)				
PD	B1	02/43119	05/30/02	WO		
↑	B2	01/01472	01/04/01	WO		
↓	B3	00/24050	04/27/00	WO		
↓	B4	00/19498	04/06/00	WO		
PD	B5	00/01012	01/06/00	WO		

Examiner

PHUC T. DANG

Date Considered

12/8/2004

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Sheet

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12

Application Number

10/732,904

Filing Date

December 10, 2003

First Named Inventor

Kim, et al.

Group Art Unit

Unassigned

2818

Examiner Name

Unassigned

Attorney Docket Number

AMAT/6826.P1/DSM/BCVD/JW

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		Number-Kind Code <sup>2</sup> (if known)			
PD	A1	US-6,472,231	10/29/02	Gabriel, et al.	
↑	A2	US-6,462,371	10/08/02	Weimer, et al.	
↑	A3	US-6,458,720	10/01/02	Aoi	
↑	A4	US-6,455,445	09/24/02	Matsuki	
↑	A5	US-6,448,186	09/10/02	Olson, et al.	
↑	A6	US-6,448,176	09/10/02	Grill, et al.	
↑	A7	US-6,441,491	08/27/02	Grill, et al.	
↑	A8	US-6,437,443	08/20/02	Grill, et al.	
↑	A9	US-6,432,417	08/13/02	Mellul, et al.	
↑	A10	US-6,428,894	08/06/2002	Babich, et al.	
↑	A11	US-6,417,098	07/09/02	Wong, et al.	
↑	A12	US-6,413,852	07/02/2002	Grill, et al.	
↑	A13	US-6,413,583	07/02/02	Moghadam, et al.	
↑	A14	US-6,410,463	06/25/02	Matsuki	
↑	A15	US-6,410,462	06/25/02	Yang, et al.	
↓	A16	US-6,383,955	05/07/02	Matsuki, et al.	
↓	A17	US-6,368,924	04/09/02	Mancini, et al.	
PD	A18	US-6,348,725	02/19/02	Cheung, et al.	

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		Number-Kind Code <sup>2</sup> (if known)				
PD	B1	99/55526	11/04/99	WO		
↑	B2	99/33102	07/01/1999	WO		
↑	B3	99/41423	08/19/99	WO		
↓	B4	99/38202	07/29/99	WO		
PD	B5	98/59089	12/30/98	WO		

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PHUC T. DANG

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**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**

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Sheet 3

of 12

Application Number	10/732,904
Filing Date	December 10, 2003
First Named Inventor	Kim, et al.
Group Art Unit	Unassigned 2818
Examiner Name	Unassigned
Attorney Docket Number	AMAT/6826.P1/DSM/BCVD/JW
Submission Date	February 18, 2004

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		Number-Kind Code <sup>2</sup> (if known)			
PD	A1	US-6,348,421	02/19/02	Shu, et al.	
	A2	US-6,346,747	02/12/02	Grill, et al.	
	A3	US-6,340,628	01/22/02	Van Cleemput, et al.	
	A4	US-6,340,435	01/22/02	Bjorkman, et al.	
	A5	US-6,316,063	11/13/01	Andideh, et al.	
	A6	US-6,312,793	11/06/01	Grill, et al.	
	A7	US-6,303,523	10/16/01	Cheung, et al.	
	A8	US-6,287,990	09/11/01	Cheung, et al.	
	A9	US-6,265,779	06/24/2001	Grill, et al.	
	A10	US-6,258,735	07/10/01	Xia, et al.	
	A11	US-6,245,690	06/12/01	Yau, et al.	
	A12	US-6,238,751	05/29/01	Mountsier	
	A13	US-6,176,198	01/23/01	Kao, et al.	
	A14	US-6,159,871	12/12/00	Loboda, et al.	
	A15	US-6,147,407	11/14/00	Jin, et al.	
	A16	US-6,147,009	11/14/00	Grill, et al.	
	A17	US-6,140,226	10/31/00	Grill, et al.	
PD	A18	US-6,124,641	09/26/00	Matsura	

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		Number-Kind Code <sup>2</sup> (if known)				
PD	B1	98/08249	02/26/98	WO		
	B2	11-251293	09/17/99	JP		
	B3	10-242143	09/11/98	JP		
	B4	09-260369	10/03/97	JP		
PD	B5	09-251997	09/22/97	JP		

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PHUC T. DANG

Date Considered

12/8/2004

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Substitute for form 1449A/PTO				Application Number	10/732,904
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>				Filing Date	December 10, 2003
(Use as many sheets as necessary)				First Named Inventor	Kim, et al.
				Group Art Unit	Unassigned 2818
				Examiner Name	Unassigned
				Attorney Docket Number	AMAT/6826.P1/DSM/BCVD/JW
Sheet	4	of	12	Submission Date	February 18, 2004

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		Number-Kind Code <sup>2</sup> (if known)			
P D	A1	US-6,093,973	07/25/00	Ngo, et al.	
↑	A2	US-6,080,526	06/27/00	Yang, et al.	
	A3	US-6,078,133	06/20/00	Menu, et al.	
	A4	US-6,072,227	06/06/00	Yau, et al.	
	A5	US-6,068,884	05/30/00	Rose, et al.	
	A6	US-6,054,379	04/25/00	Yau, et al.	
	A7	US-6,048,786	04/11/00	Kudo	
	A8	US-6,054,206	04/25/00	Mountsier	
	A9	US-6,051,321	04/18/00	Lee, et al.	
	A10	US-6,030,904	02/29/00	Grill, et al.	
	A11	US-6,037,274	03/14/00	Kudo, et al.	
	A12	US-6,007,732	12/28/99	Hashimoto, et al.	
	A13	US-5,998,100	12/07/99	Azuma, et al.	
	A14	US-5,989,998	11/23/99	Sugahara, et al.	
	A15	US-5,981,000	11/09/99	Grill, et al.	
↓	A16	US-5,926,740	07/20/99	Forbes, et al.	
↓	A17	US-5,891,799	04/06/99	Tsui	
P D	A18	US-5,888,593	03/30/99	Petrmichl, et al.	

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		Number-Kind Code <sup>2</sup> (if known)				
P D	B1	09-237785	09/09/97	JP		
↑	B2	09-064029	03/07/97	JP		
	B3	09-008031	01/10/97	JP		
↓	B4	01-125193	05/17/89	JP		
P D	B5	2000306999 (abstract)	11-02/00	JP		

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Substitute for form 1449A/PTO		Application Number	10/732,904		
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		Group Art Unit	Unassigned 2818		
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Sheet	5	of	12	Submission Date	February 18, 2004

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PD	A1	US-5,874,367	02/23/99	Dobson	
↑	A2	US-5,858,880	01/12/99	Dobson, et al.	
	A3	US-5,837,331	11/17/98	Menu, et al.	
	A4	US-5,834,162	11/10/98	Malba	
	A5	US-5,830,332	11/03/98	Babich, et al.	
	A6	US-5,821,168	10/13/98	Jain	
	A7	US-5,807,785	09/15/98	Ravi	
	A8	US-5,800,877	09/01/98	Maeda, et al.	
	A9	US-5,795,648	08/18/98	Goel, et al.	
	A10	US-5,789,319	08/04/98	Havemann, et al.	
	A11	US-5,780,874	07/14/98	Kudo	
	A12	US-5,773,199	06/30/98	Linliu, et al.	
	A13	US-5,753,564	05/19/98	Fukada	
	A14	US-5,753,319	05/19/98	Knapp, et al.	
↓	A15	US-5,750,316	05/12/98	Kawamura, et al.	
	A16	US-5,739,579	04/14/98	Chiang, et al.	
↓	A17	US-5,703,404	12/30/97	Matsuura	
PD	A18	US-5,700,720	12/23/97	Hashimoto	

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		Number-Kind Code <sup>2</sup> (if known)				
PD	B1	2 316 535	02/25/98	GB		
↑	B2	1 176 226 A1	01/30/02	EP		
	B3	1 123 991 A2	08/16/01	EP		
↓	B4	1 037 275 A1	09/20/00	EP		
PD	B5	0 935 283 A2	08/11/99	EP		

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↑	A2	US-5,683,940	11/04/97	Yahiro	
	A3	US-5,679,413	10/21/97	Petrmichl, et al.	
	A4	US-5,679,269	10/21/97	Cohen, et al.	
	A5	US-5,674,355	10/07/97	Cohen, et al.	
	A6	US-5,641,607	06/24/97	Ogawa, et al.	
	A7	US-5,638,251	06/10/97	Goel, et al.	
	A8	US-5,637,351	06/10/97	O'Neal, et al.	
	A9	US-5,618,619	04/08/97	Petrmichl, et al.	
	A10	US-5,616,369	04/01/97	Williams, et al.	
	A11	US-5,599,740	02/04/97	Jang, et al.	
	A12	US-5,598,027	01/28/97	Matsuura	
	A13	US-5,593,741	01/14/97	Ikeda	
	A14	US-5,591,566	01/07/97	Ogawa	
↓	A15	US-5,559,367	09/24/96	Cohen, et al.	
	A16	US-5,494,712	02/27/96	Hu, et al.	
↓	A17	US-5,360,491	11/01/94	Carey, et al.	
PD	A18	US-5,298,587	03/29/94	Hu, et al.	

## FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
		Number-Kind Code <sup>2</sup> (if known)				
PD	B5	0 926 724 A2	06/30/99	EP		
↑	B1	0 926 715 A2	06/30/99	EP		
	B2	0 960 958 A2	12/01/99	EP		
↓	B3	0 935 283 A2	08/11/99	EP		
PD	B4	0 885 983 A1	12/23/98	EP		

Examiner P H V C T. DANG

Date Considered 12/18/2004

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Substitute for form 1449A/PTO				Application Number	10/732,904
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Filing Date	December 10, 2003
(Use as many sheets as necessary)				First Named Inventor	Kim, et al.
				Group Art Unit	Unassigned 2818
				Examiner Name	Unassigned
				Attorney Docket Number	AMAT/6826.P1/DSM/BCVD/JW
Sheet	7	of	12	Submission Date	February 18, 2004

## U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code <sup>2</sup> (if known)			
PD	A1	US-5,186,718	02/16/93	Tepman, et al.	/
↑	A2	US-4,486,286	12/04/84	Lewin, et al.	/
	A3	US-2003/0111730A1	06/19/2003	Takeda, et al.	/
	A4	US-2003/0091938	05/15/03	Fairbairn, et al.	/
	A5	US-2003/0089988A1	05/15/2003	Matsuura	/
	A6	US-2003/0020108	05/15/2003	Matsuura	/
	A7	US-2003/0017718	01/23/03	Aoi	/
	A8	US-2003/0003765A1	01/02/2003	Gibson, Jr., et al.	/
	A9	US-2003/0001239	01/02/03	Gallahger, et al.	/
	A10	US-2002/0198353	12/26/02	Chen, et al.	/
	A11	US-2002/0192982	12/19/02	Andideh, et al.	/
	A12	US-2002/0185741	12/12/02	Babich, et al.	/
	A13	US-2002/0177329	11/28/02	Yang, et al.	/
	A14	US-2002/0177303	11/28/02	Jiang, et al.	/
	A15	US-2002/0173172	11/21/02	Loboda, et al.	/
↓	A16	US-2002/0173157	11/21/02	Chang, et al.	/
↓	A17	US-2002/0168870	11/14/02	Matsuki	/
PD	A18	US-2002/0164891	11/07/02	Gates, et al.	/

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		Number-Kind Code <sup>2</sup> (if known)				
PD	B1	0 849 789 A2	06/24/98	EP		
↑	B2	0 840 365 A2	06/05/98	EP		
	B3	0 826 791 A2	03/04/98	EP		
↓	B4	0 774 533 A1	05/21/97	EP		
PD	B5	0 771 886 A1	05/07/97	EP		

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Date Considered

12/8/2004

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## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Sheet 8

of 12

Application Number 10/732,904

Filing Date December 10, 2003

First Named Inventor Kim, et al.

Group Art Unit Unassigned 2815

Examiner Name Unassigned

Attorney Docket Number AMAT/6826.P1/DSM/BCVD/JW

Submission Date February 18, 2004

### U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code <sup>2</sup> (if known)			
P D	A1	US-2002/0164868	11/07/02	Chang, et al.	
	A2	US-2002/0160626	10/31/02	Matsuki, et al.	
	A3	US-2002/0160604	10/31/02	Quek, et al.	
	A4	US-2002/0158337 A1	10/31/02	Babich, et al.	
	A5	US-2002/0127844 A1	09/12/02	Grill, et al.	
	A6	US-2002/0105084	08/08/02	Li	
	A7	US-2002/0098714	07/25/02	Grill, et al.	
	A8	US-2002/0098684	07/25/02	Li, et al.	
	A9	US-2002/0076944	06/20/02	Wang, et al.	
	A10	US-2002/0068458	06/06/02	Chiang, et al.	
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	A12	US-2002/0028392 A1	03/07/02	Jin, et al.	
	A13	US-2001/0022398	09/20/01	Grill, et al.	
	A14	US-2001/0021590	09/13/01	Matsuki	
	A15	US-2001/0005546	06/28/01	Cheung, et al.	
P D	A16	US-2001/0004479	06/21/01	Cheung, et al.	

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		Number-Kind Code <sup>2</sup> (if known)				
P D	B1	0 224 013	06/03/87	EP		
	B2	0 768 388 A2	04/16/97	EP		
	B3	0 696 819 A1	02/14/96	EP		
	B4	0 701 283 A2	03/13/96	EP		
	B5	199 04 311 A1	08/12/99	DE		
	B6	198 04 375 A1	01/07/99	DE		
P D	B7	196 54 737 A1	07/03/97	DE		

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Date Considered

12/8/2004

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Substitute for form 1449B/PTO				Application Number	10/732,904
<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>				Filing Date	December 10, 2003
(Use as many sheets as necessary)				First Named Inventor	Kim, et al.
				Group Art Unit	Unassigned 2818
				Examiner Name	Unassigned
				Attorney Docket Number	AMAT/6826.P1/DSM/BCVD/JW
Sheet	9	of	12	Submission Date	February 18, 2004

NON PATENT LITERATURE DOCUMENTS				
Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published		
P D	C1	Robles, et al. <i>Characterization of High Density Plasma Chemical Vapor Deposited x-Carbon and x-Fluorinated Carbon Films for Ultra Low Dielectric Application</i> , February 10-11, 1997 DUMIC Conference, pgs. 26-33		T <sup>2</sup>
	C2	Bar-Ilan, et al. <i>A Comparative Study of Sub-Micro Gap Filling and Planarization Techniques</i> , Tower Semiconductor Ltd., Israel, SPIE Vol. 2636, pgs. 277-288		
	C3	Hazari, et al., <i>Characterization of Alternative Chemistries for Depositing PECVD Silicon Dioxide Films</i> , Novellus Systems, Inc., San Jose, CA February 16-17, 1998, pgs. 319-326		
	C4	McClatchie, <i>Low Dielectric Constant Oxide Films Deposited Using CVD Techniques</i> , February 16-17, 1998 DUMIC Conference, pgs. 311-318		
	C5	Reif, et al., <i>Environmental, Safety, and Health Issues in IC Production</i> , Mat. Res. Soc. Symposium Proceedings Vol. 447, December 4-5, 1996 (6 pages)		
	C6	Laboda, et al., <i>Deposition of Low-k Dielectric Films Using Trimethylsilane</i> , Electro. Chem. Soc., Vol. 98-6, pgs. 145-152		
	C7	Zhao, et al., <i>Integration of Low Dielectric Constant Materials in Advanced Aluminum and Copper Interconnects</i> , Conexant Systems, 1999 pgs. 485-497		
	C8	Sugahara, et al., <i>Low Dielectric Constant Carbon Containing SiO<sub>2</sub> Films Deposited by PECVD Technique Using a Novel CVD Precursor</i> , February 10-11, 1997 DUMIC Conference, pgs. 19-25		
	C9	Nara, et al., <i>Low Dielectric Constant Insulator Formed by Downstream Plasma CVD at Room Temperature Using TMS/O<sub>2</sub></i> , ULSI Research Lab, November 14, 1996, pgs. 1477-1480		
P D	C10	Deen, et al. <i>Silicon Nitride and Silicon Dioxide Thin Insulating Films</i> , Dielectric Science and Tech and Electronics Div. Proceedings, Vol. 97-10, pgs. 443-453		

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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>				Filing Date	December 10, 2003
(Use as many sheets as necessary)				First Named Inventor	Kim, et al.
				Group Art Unit	Unassigned 2818
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Sheet	10	of	12	Submission Date	February 18, 2004

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PD	C11	Brown, <i>Dielectric Material Integration for Microelectronics</i> , Dielectric Science and Technology and Elect Divisions Proceedings, Vol. 98-3 (8 pages)		T <sup>2</sup>
	C12	Grill, et al., <i>Novel Low-k Dielectrics Based on Diamondlike Carbon Materials</i> , IBM Research Division, pgs. 1649-1653		
	C13	Lin, et al., <i>Plasma Polymerization of Trimethylsilane in Cascade Arc Discharge</i> , Dept. of Chem. Engineering and Center for Surface Science and Plasma Technology, University of Missouri-Columbia, February 4, 1997, pgs. 1653-1665		
	C14	Peters, <i>Pursuing the Perfect Low-K Dielectric</i> , 64 Semiconductor International, September 1998, (7 pages)		
	C15	Grill, et al., <i>Low Dielectric Constant Films Prepared by Plasma-enhanced Chemical Vapor Deposition from Tetramethylsilane</i> , IBM Research Division, pgs. 3314-3318		
	C16	Wrobel, et al. <i>Reactivity of Alkylsilanes and Alkylcarbosilanes in Atomic Hydrogen-induced Chemical Vapor Deposition</i> , Polish Academy of Sciences, Centre of Molecular and Macromolecular Studies, pgs. 1060-1065		
	C17	Mahorowala, et al., <i>Tunable Anti-Reflective Coatings with Built-in Hard Mask Properties Facilitating Thin Resist Processing</i> , Proceedings of SPIE, Vol. 4343 (2001) pgs. 306-316		
	C18	Singer (editor), <i>Anti-Reflective Coatings: A Story of Interfaces</i> , Semiconductor International, March 1999		
	C19	Taylor, et al., <i>Parylene Copolymers</i> , Texas Instruments, Inc., 1997, pgs. 1-9		
PD	C20	Grill, et al., <i>Diamondlike Carbon Materials as Low-k Dielectrics</i> , Mat. Res. Soc., 1997, pgs. 417-423		

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**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**

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Sheet 11

of 12

Application Number	10/732,904
Filing Date	December 10, 2003
First Named Inventor	Kim, et al.
Group Art Unit	Unassigned 2818
Examiner Name	Unassigned
Attorney Docket Number	AMAT/6826.P1/DSM/BCVD/JW

Submission Date

February 18, 2004

**NON PATENT LITERATURE DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T <sup>2</sup>
PD	C21	Wu, et al "Advanced Metal Barrier Free Cu Damascene Interconnects with PECVD Silicon Carbide Barriers for 90/65-nm BEOL Tech", 2002 IEEE, IEDM P 595-598.	
	C22	Licata, et al. "Dual Damascene Al Wiring For 256M DRAM; June 27-29, 1995 VMIC Conference, 1995 ISMIC - 104/95/0596	
	C23	Endo, Kazuhiko; and Tatsumi, Toru, "Preparation and Properties of Fluorinated Amorphous Carbon Thin Films by Plasma Enhanced Chemical Vapor Deposition", Mat. Res. Soc. Symp. Proc. Vol. 381, 1995	
	C24	Nguyen, et al. "A Novel Damascene Process for One Mask Via/Interconnect Formation", 1996 Symposium on VLSI Tech Digest of Technical Papers.	
	C25	Lakshminarayanan, et al., "Contact and Via Structures with Coper Interconnects Fabricated Using Dual Damascene Technology", IEEE Electron Device Letters, Vol. 15, No. 8, August 1994.	
	C26	Grill, et al. "Diamondlike Carbon Films by rf plasma assisted chemical vapor deposition from acetylene", IBM J. Res. Dev. Vol. 34 No. 6 Nov. 1990.	
	C27	Kaanta, et al., "Dual Damascene: A ULSI Wiring Technology", June 11-12, 1991 VMIC Conference, TH-0359-0/91/0000-0144.	
	C28	Hasegawa, et al. "Copper Dual Damascene Interconnects with Low-K ( $K_{eff} < 3.0$ ) Dielectrics Using Flare <sup>th</sup> and an Organo-Silicate Hard Mask", LSI Business & Technology Development Group, C.N.C. Sony Corporation; IEDM 99-623; pgs 26.4.1 – 26.4.4	
	C29	U.S. Application 10/375,852 filed on February 25, 2003.(AMAT/2592.C5)	
PD	C30	U.S. Application 10/196,498 filed on July 15, 2002 (AMAT/6084)	

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Date Considered 12/8/2004

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PTO/SB/08b (08-03)

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Substitute for form 1449B/PTO			Application Number	10/732,904	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT			Filing Date	December 10, 2003	
(Use as many sheets as necessary)			First Named Inventor	Kim, et al.	
			Group Art Unit	Unassigned 2818	
			Examiner Name	Unassigned	
			Attorney Docket Number	AMAT/6826.P1/DSM/BCVD/JW	
Sheet	12	of	12	Submission Date	February 16, 2004

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T <sup>2</sup>				
PD	C31	U.S. Application 10/247,404 filed on June 19, 2002 (AMAT/6084.P1)		
PD	C32	U.S. Application 10/096,503 filed on March 12, 2002 (AMAT/6084.02)		
PD	C33	U.S. Application 09/627,667 filed on July 28, 2000.(AMAT/4683)		
PD	C34	U.S. Application 10/122,106 filed on April 11, 2002. (AMAT/6166)		
	C35			
	C36			
	C37			
	C38			
	C39			
	C40			
	C41			

Examiner

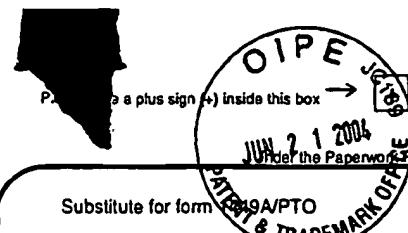
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Sheet 1

of 2

Application Number	10/732,904
Filing Date	DECEMBER 10, 2003
First Named Inventor	KIM, ET AL.
Group Art Unit	2818
Examiner Name	UNKNOWN
Attorney Docket Number	AMAT/6826.P1/DSM/BCVD/JW

Submission Date June 16, 2004

**U.S. PATENT DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code <sup>2</sup> (if known)			
PD	A1	US-6,720,251 B1	04/13/2004	Van Schravendijk, et al.	
↑	A2	US-6,500,773 B1	12/31/2002	Gaillard, et al.	
	A3	US-6,340,628 B1	01/22/2002	Van Cleemput	
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	A6	US-2002/0172766 A1	11/21/2002	Laxman, et al.	
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	A9	US-			
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	A16	US-			
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	A18	US-			

**FOREIGN PATENT DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
		Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>5</sup> (if known)				
PD	B1	EP 1 209 728 A2	05/29/2002	Ellie Yieh		
PD	B2	EP 1 061 156 A2	12/20/2000	Judy Huang		
	B3					
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Examiner

PHUC T. DANG

Date Considered

12/8/2004

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